

(19)



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(11)

EP 0 499 488 B9

(12)

CORRECTED EUROPEAN PATENT SPECIFICATION

Note: Bibliography reflects the latest situation

(15) Correction information:

**Corrected version no 1 (W1 B1)
Corrections, see page(s) 8**

(51) Int Cl.7: **H01L 21/306, H01L 21/20,
H01L 21/76**

(48) Corrigendum issued on:

28.01.2004 Bulletin 2004/05

(45) Date of publication and mention
of the grant of the patent:

09.07.2003 Bulletin 2003/28

(21) Application number: **92301252.0**

(22) Date of filing: **14.02.1992**

(54) **Etching solution for etching porous silicon, etching method using the etching solution and method of preparing semiconductor member using the etching solution**

Ätzlösung für das Ätzen von porösem Silizium, Ätzmethode unter Verwendung der Ätzlösung und Verfahren zur Vorbereitung einer Halbleiteranordnung unter Verwendung der Ätzlösung

Solution d'attaque pour attaquer le silicium poreux, méthode d'attaque utilisant ladite solution, et procédé de préparation d'un composant semi-conducteur utilisant ladite solution

(84) Designated Contracting States:

AT BE CH DE DK ES FR GB GR IT LI LU NL PT SE

(30) Priority: **15.02.1991 JP 4221291**

15.02.1991 JP 4221391

28.02.1991 JP 5560691

28.02.1991 JP 5560591

28.02.1991 JP 5560491

28.02.1991 JP 5560391

28.02.1991 JP 5560291

28.02.1991 JP 5560191

28.02.1991 JP 5561491

28.02.1991 JP 5561391

28.02.1991 JP 5561291

28.02.1991 JP 5561191

28.02.1991 JP 5561091

28.02.1991 JP 5560891

28.02.1991 JP 5560791

28.02.1991 JP 5560991

27.03.1991 JP 8575591

24.05.1991 JP 14816091

24.05.1991 JP 14816191

24.05.1991 JP 14816391

24.05.1991 JP 14816491

28.05.1991 JP 15098991

28.05.1991 JP 15098091

28.05.1991 JP 15099491

28.05.1991 JP 15099091

28.05.1991 JP 15099191

28.05.1991 JP 15099291

28.05.1991 JP 15098191

28.05.1991 JP 15098291

28.05.1991 JP 15098391

28.05.1991 JP 15098491

28.05.1991 JP 15098591

29.05.1991 JP 15224991

29.05.1991 JP 15224891

27.05.1991 JP 14930291

27.05.1991 JP 14929791

27.05.1991 JP 14929891

27.05.1991 JP 14930091

27.05.1991 JP 14929991

27.05.1991 JP 14930191

28.05.1991 JP 15099391

29.05.1991 JP 15225091

29.05.1991 JP 15225191

27.05.1991 JP 14931091

27.05.1991 JP 14930691

27.05.1991 JP 14930791

27.05.1991 JP 14930891

27.05.1991 JP 14930991

27.05.1991 JP 14931191

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